



Order form (version 3) for  
**Ion Implantation**

Ordered by ..... Telephone .....

Account no.\* .....

Implantation date\* .....

Ion .....

Tilt angle .....

Target heating .....

Batch no.\* .....

General comments\* .....  
.....

Wafer no.	Target Position*	Energy (keV)	Dose (cm <sup>-2</sup> )	Comments*

\* Optional information, or filled in by operator

Operator\* .....